

IFW



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77313

Shinya YAMASAKI, et al.

Appln. No.: 10/665,148

Group Art Unit: 1763

Confirmation No.: 5798

Examiner: Macarthur, Sylvia

Filed: September 22, 2003

For: ETCHING AND CLEANING METHODS AND ETCHING AND CLEANING
APPARATUS USED THEREFOR

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 29, 2004, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS	2
REMARKS.....	12